

<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>		<b>ATTY. DOCKET NO.</b> P123-US		<b>SERIAL NO.</b> 16/698,290 <del>Not Yet Assigned</del>			
		<b>APPLICANT</b> Peter W. Richards					
		<b>FILING DATE</b> Herewith		<b>GROUP</b> <del>Not Yet Assigned</del> 287.3			
<b>U.S. PATENT DOCUMENTS</b>							
<b>EXAMINER'S INITIALS</b>	<b>PATENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>	
JP	US2002/0085438 A1	07/04/02	Wolverton	365	200		
	US2002/0138688 A1	09/26/02	Hsu, et al.	711	105		
	US2002/0054031 A1	05/09/02	Elliott, et al.	345	204		
	6,421,285	07/16/02	Matsuzaki, et al.	365	200		
	5,903,248	05/11/99	Irwin, et al.	345	90		
	4,638,309	01/20/87	Ott	345	84		
	6,344,672 B2	02/05/02	Huffman	257	296		
	5,132,928	07/21/92	Hayashikoshi, et al.	365	185.13		
	5,382,961	01/17/95	Gale, Jr.	345	108		
<b>FOREIGN PATENT DOCUMENTS</b>							
<b>EXAMINER'S INITIALS</b>	<b>PATENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>	
						<b>YES</b>	<b>NO</b>
						<input type="checkbox"/>	<input type="checkbox"/>
						<input type="checkbox"/>	<input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
JP	Kompenhouwer, et al., OPTIMALLY REDUCING MOTION ARTIFACTS IN PLASMA DISPLAYS, Phillips Research Laboratories, SID 00 Digest, Pgs 388-391. <b>YEAR 2000</b>						
JP	Baker, et al., CMOS Circuit Design, Layout and Simulation, IEEE Press Series on Microelectronic Systems, IEEE Press, New York, Pgs 345-349. <b>DATE N/A</b>						

<b>INFORMATION DISCLOSURE CITATION</b>  <b>PTO-1449</b>		ATTY. DOCKET NO. P123-US		SERIAL NO. 10/698,290 <del>Not Yet Assigned</del>			
		APPLICANT Peter W. Richards					
		FILING DATE Herewith		GROUP <del>Not Yet Assigned</del> 2873			
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	5,523,803	06/04/96	Urbanus, et al.	348	771		
	5,255,100	10/19/93	Urbanus	348	441		
	6,115,083	09/05/00	Doherty, et al.	348	771		
	6,107,979	08/22/00	Chiu, et al.	345	84		
	5,079,544	01/07/92	DeMond, et al.	345	84		
	5,548,301	08/20/96	Kornher, et al.	345	85		
	5,254,980	10/19/93	Hendrix, et al.	345	84		
	5,444,566	08/22/95	Gale, et al.	359	291		
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
						<input type="checkbox"/>	<input type="checkbox"/>
						<input type="checkbox"/>	<input type="checkbox"/>
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EXAMINER <u>JACK DINI</u>		DATE CONSIDERED <u>10/05/04</u>					

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.